NO. 8341

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Venkat Selvamanickam

Title:

HIGH-THROUGHPUT EX-SITU METHOD FOR RARE-EARTH-

BARIUM-COPPER-OXIDE (REBCO) FILM GROWTH

App. No.:

10/736,223

Filed:

December 15, 2003

Examiner:

Brian K. Talbot

Group Art Unit:

1762

Customer No.: 34456

Confirmation No.:

3138

Atty. Dkt. No.: 1014-SP165-US

MS AMENDMENT Commissioner for Patents

PO Box 1450

Alexandria, VA 22313-1450

## RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action mailed March 31, 2006, please amend the aboveidentified application as follows:

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents on 7-19-06 addressed to the Commissioner for Patents on

Debra J. Gillooly

Typed or Printed Name

Signature